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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/710,482	07/14/2004	Silviu REINHORN	Silviu REINHORN 6629C01\USA\PDC\ORBOT\OR 4481	
44988 7	590 02/24/2005		EXAM	MINER
SUGHRUE MION, PLLC 401 CASTRO STREET		STEVENSO	N, ANDRE C	
SUITE 220	STREET		ART UNIT	PAPER NUMBER
MOUNTAIN V	VIEW, CA 94041-2007		2812	

DATE MAILED: 02/24/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)				
Office Action Summers	10/710,482	REINHORN, SILVIU				
Office Action Summary	Examiner	Art Unit				
	Andre' C. Stevenson	2812				
The MAILING DATE of this communication app Period for Reply	ears on the cover sheet with the c	orrespondence address				
A SHORTENED STATUTORY PERIOD FOR REPLY THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a reply If NO period for reply is specified above, the maximum statutory period w Failure to reply within the set or extended period for reply will, by statute, Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	36(a). In no event, however, may a reply be time within the statutory minimum of thirty (30) days will apply and will expire SIX (6) MONTHS from cause the application to become ABANDONE	nely filed s will be considered timely. the mailing date of this communication. D (35 U.S.C. § 133).				
Status						
1) Responsive to communication(s) filed on 14 Ju	<u>ıly 2004</u> .					
2a) ☐ This action is FINAL . 2b) ☒ This	action is non-final.					
Disposition of Claims						
 4) Claim(s) 1-15 is/are pending in the application. 4a) Of the above claim(s) is/are withdraw 5) Claim(s) 14 and 15 is/are allowed. 6) Claim(s) 1-4 and 6-13 is/are rejected. 7) Claim(s) 5 is/are objected to. 8) Claim(s) are subject to restriction and/or 	vn from consideration.					
Application Papers						
9) The specification is objected to by the Examine		the English				
10) ☐ The drawing(s) filed on 14 July 2004 is/are: a) ☐ Applicant may not request that any objection to the company of the co						
Replacement drawing sheet(s) including the correcti	•	, ,				
11) The oath or declaration is objected to by the Ex	• • • • •	• • • • • • • • • • • • • • • • • • • •				
Priority under 35 U.S.C. § 119						
 12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of: 1. Certified copies of the priority documents 2. Certified copies of the priority documents 3. Copies of the certified copies of the priority application from the International Bureau 	s have been received. s have been received in Application ity documents have been receive	on No				
* See the attached detailed Office action for a list	of the certified copies not receive					
Attachment(s)	PI	LYNNE A. GURLEY RIMARY PATENT EXAMINER				
1) X Notice of References Cited (PTO-892)	4)	TC 2800, AU 2512 (PTO-413)				
2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date 07/14/04.		ite atent Application (PTO-152)				

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Detailed Action

Information Disclosure Statement

The information disclosure statement (IDS) submitted on July 14, 2004 was filed before the first action on the merits. The submission is in compliance with the provisions of 37 CFR 1.97. Accordingly, the information disclosure statement is being considered by the examiner.

Claim Objections

Claim #4, objected to because of the following informalities: In claim #4, line 5, applicant states, "circular beam in based on the imaging operation type". The Examiner believes that the applicant was intended to say, "circular beam based on the imaging operation type." For clarity purposes, appropriate correction is required.

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- ((b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- ((e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this



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subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.

Claims 1-4, 6, 11 and 12 are rejected under 35 U.S.C. 102(b) as being anticipated by Ando (U.S. Pat. No.5,349,592, Patented 09/20/94, Filed 02/25/03).

Ando shows, in figures 1-53 and corresponding text, with respect to claim #1, a method for optical inspection, comprising; generating an annular light beam (fig. 2, item 10 which produces the annular beam from leaser element beam #112; column 6, lines 3-45; column 7, lines 33-43); scanning the annular beam along a line in a given scanning direction to provide a scanned single beam (item 118 and 120) scans the beam into a single beam focused on the R_m; column 6, lines 57-60; column 7, lines 33-67); and splitting the scanned single beam to provide multiple beams of substantially identical intensity from the scanned single beam (light reflected from R_m, column 8, lines 1-13); and detecting signals (detector items 128 and 130) generated from an interaction between the plurality of multiple beams and an inspected object (R_m is the inspected object; column 8, lines 4-13). Pertaining to Claim #2, Ando shows an optical inspection method, comprising of outputting an annular beam from a light source (fig. 2, item 10, produces annular beam from light source 112; column 6, lines 3-45; column 7, lines 33-43); focusing the annular beam at a target (column 7, lines 52-55, target R_m); and detecting light scattered from the target (detector 128 and 130, column 8, lines 4-13). Pertaining to claim #3, Ando also shows, an optical inspection method further comprising; outputting a circular beam from the light source (fig. 2, item 10; column 6, lines 3-45; column 7, lines 55-64 note that the annular beam is also circular beam); focusing the circular beam at the target (column 7, lines 52-55); and detecting light reflected from the target (column 8, lines 4-13). Pertaining to claim #4, Ando shows, an optical inspection method further comprising: selecting an imaging

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operation type; producing a selected one of the annular beam and the circular beam based on the imaging operation type (both annular and circular portions are used for inspection, (column 7, lines 65-67; column 8, lines 1-13). Pertaining to claim #6, Ando shows, an optical inspection method, further comprising: scanning the annular beam along a line in a given scanning direction to provide and a scanned single annular beam; producing multiple annular beams of substantially identical intensity from the scanned single annular beam (column 16, lines 7-22; column 6, lines 57-60; column 7, lines 33-67). Pertaining to claim #11, Ando shows, an optical inspection method, comprising; outputting a beam (item #112); focusing the beam at a target (R_m), and directing captured light to a detector through a confocal optical arrangement (item 124, 126 and 128)(column 18, lines 50-55 and lines 63-57; column 19, lines 1, 2). Pertaining to claim #12, Ando also shows, an optical inspection method further comprising controlling the focus of the optics (column 26, lines 1-14) based on: a light level threshold, and a light level signal indicative of light received by the detector through the confocal optical arrangement (column 18, lines 50-55 and lines 63-57; column 19, lines 1, 2).

Claims #7, 9, 10 and 13 are rejected under 35 U.S.C. 102(e) as being anticipated by Hill (U.S. Pat. No.6,271,923, Patented 08/07/01, Filed 07/27/99).

Hill shows, in figures 1-53 and corresponding text, with respect to claim #7, an optical inspection method, comprising: outputting a single beam; scanning the single beam along a line in a given scanning direction to provide a scanned single beam (column 3, lines 10-14); and producing multiple beams of substantially identical intensity from the scanned single beam (column 3, lines 14-32). *Pertaining to claim #9*, Hill shows, an optical inspection method,

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comprising outputting a beam (column 3, lines 10-14) and scanning the beam in a beam Spot across a target the target being movable in a target movement direction; wherein the beam has a scanning direction not perpendicular to the target movement direction (fig. 1; column 6, lines 32-44; column 3, lines 14-32). Pertaining to claim #10, Hill shows, an optical inspection method, wherein the beam spot travels a distance in the mechanical scanning direction that is greater than the distance in between scan lines in the mechanical scanning direction (fig. 6a items 533, 534 and a; fig. 5a items 433, 434 and a; column 25, lines 28-49; column 26, lines 30-53). The Examiner notes that although no specific measurement of the mechanical distance between the two beams, nor the mechanical distance that they travel, is explicitly mentioned, the observation of the drawings, listed above, along with corresponding text, shows that the mechanical distance that the two beams travel, is greater that than the mechanical distance between them. *Pertaining to claim #13*, Hill shows, an optical inspection method, comprising; providing a beam of light (column 16, lines 13-19); providing scanned multiple beams from the beam of light (fig. 2, item 120, 142, 143 and 166; column 3, lines 9-17); illuminating a target, with the scanned multiple beams, through an objective lens (column 3, lines 17-23); collecting light, returned back from the illuminated target, with the objective lens; passing the collected light through to an imaging lens (column 3, lines 23-32); focusing the light of the imaging lens to a bright field channel detector (fig. 2, items 128 and 182; column 3, lines 43-53; column 17, lines 3-36). The Examiner notes that even through bright field channel detector is not explicitly disclosed, the detector detects a circular beam, which would make it a bright field detector.

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claim #8 is rejected under 35 U.S.C. 103(a) as being unpatentable over Hill (U.S. Pat. No.6,271,923, Patented 08/07/01, Filed 07/27/99) as applied to claim #7 above, and in view of Tanitsu et al. (U.S. Pat. No.6,741,394 B1, Patented 05/25/04, Filed 11/02/00).

Hill shows the method substantially as claimed and as described in the previous rejection of claim #7 under 35 USC 102(e).

Hill fails to show, pertaining to claim #8 wherein producing of the multiple beams is performed with a diffractive optical element having uniform diffraction efficiency.

Tanitsu teaches, in a similar method, wherein a diffractive element, with uniform diffraction efficiency is used, with respect to claim #8, in an optical inspection method, wherein the production of multiple beams is performed with a diffractive optical element having uniform diffraction efficiency (column 5, lines 42-47).

It would have been obvious to one having ordinary skill in the art, at the time the invention was made, to use a diffractive element with uniform diffraction efficiency to produce multiple beams, in the method of Hill, as taught by Tanitsu, with the motivation given by Tanitsu, in column 5, lines 42-47, that the resulting method allows for controlling the form of the secondary light source (i.e. precluding the quantity and quality of the diffracted light from

diminishing as the zeroth-order of light is maintained), so that the beam will maintain a concentrated focus.

Allowable Subject Matter

Claim #5 is objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.

Claim #5 allowable subject matter subject to further search.

> When the imaging operation type is bright field imaging, the light source is controlled to produce the circular beam.

The following is an examiner's statement of reasons for allowance: The prior art shows an optical system first and second beam splitters and the illumination of a target through a objective lens system. It fails to teach deflecting the returned light signal, with the first beam splitter, through a focusing lens and a pinhole, and receiving the light through the pinhole using one or more detectors.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Claims 14 and 15 are allowed subject to an updated search.

Claim #14 and 15 allowable subject matter:



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✓ Deflecting the returned light signal, with the first beam splitter, through a focusing lens and a pinhole, and receiving the light through the pinhole using one or more detectors.

Conclusion

The prior art made of record and not relied upon is considered pertinent to applicant's disclosure; Bultman et al. (U.S. Pat. No. 6,829,559), Reddersen et al. (U.S. Pat. No. 5,438,187), Hayano (U.S. Pat. No. 5,719,405), Conemac (U.S. Pat. No. 6,226,126).

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Andre' Stevenson whose telephone number is (571) 272 1683. The examiner can normally be reached on Monday through Friday from 7:30 am to 4:30 pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Michael S. Lebentritt, can be reached on (571) 272 1873. The fax phone number for the organization where this application or proceeding is assigned is (703) 308 7724.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308 0956. Also, the proceeding numbers can be used to fax information through the Right Fax system;

(703) 872-9306

Andre' Stevenson

02/11/05

LYNNE A. GURLEY

PRIMARY PATENT EXAMINER

TC 2800, AU 2812